

EL979953725

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

priority Application Serial No. 10/092,874
Confirmation No. unknown
priority Filing Date March 5, 2002
Inventor..... Y. Hishiro
Assignee Micron Technology, Inc.
Group Art Unit..... unknown
Examiner unknown
Attorney's Docket No. MI22-2507
Customer No. 021567
Title: Methods Of Forming Semiconductor Constructions

PRELIMINARY AMENDMENT

To: Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: David G. Latwesen, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

AMENDMENTS